

Group Art Unit: 3663

In re the Application of: Katsuto TANAHASHI et al.

Examiner: Johannes P. Mondt

Filed: December 24, 2003

Application Number: 10/743,793

Confirmation Number: 9788

For: SEMICON

SEMICONDUCTOR SUBSTRATE AND MANUFACTURING

METHOD THEREOF

Attorney Docket Number:

032206

Customer Number:

38834

AMENDMENT UNDER 37 C.F.R. §1.116 EXPEDITED PROCESSING REQUESTED

MAIL STOP AF

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 November 21, 2006

Sir:

In response to the Office Action dated July 21, 2006, the response date of which having been extended by one month to November 21, 2006, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.